IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT

Inventor(s):	Shiu-Ko Jangjian, et al.	Docket No.:	39524.8100
Serial No.:	10/679,764	Filing Date:	October 6, 2007
Art Unit:	1792	Examiner:	David P Turocy
TITLE:	METHOD OF FORMING INTER-METAL DIELECTRIC LAYER STRUCTURE	Confirmation No.:	8562

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Dear Honorable Commissioner:

In response to the Notice of Non-Compliant Amendment mailed on November 15, 2007, in connection with U.S. Patent Application No. 10/679,764, Applicant hereby submits a revised listing of the claims.